# Electronic Information Disclosure Statement

# Microneedle Devices and Methods of Manufacture and Use Thereof

Application:

Confirmation: 4309

TECHNOLOGY CENTER R3700 Applicant(s): Mark Allen

Docket

BVTP-P04-506

Number: **Group Art** 

3763

Unit:

Thompson, Kathryn L. Examiner:

( 4320758 or 4664651 or 4671288 or 4703761 or 4775361 or 5035711 or 5147355 or 5599302

or 5605662 or 5611942 or 5632957 or 5758505 or 5807375 or 5848991 or 5852495 or 5855801

search string: or 5858188 or 5865786 or 5865796 or 5876675 or 5883211 or 5885211 or 5899880 or 5911223

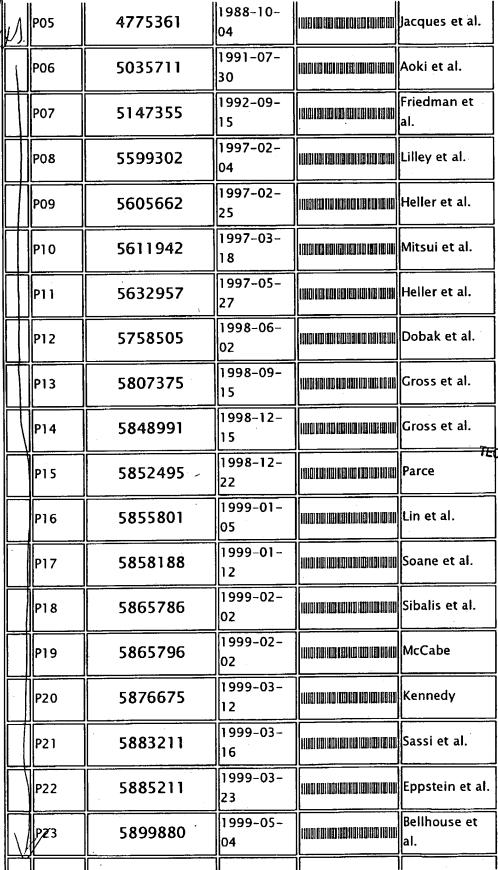
or 5919159 or 20010053891 ).pn.

## **US Patent Documents**

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

	init	Citation No.	Patent Number	Date	Bar Code	Patentee	Class	Subclass
	14	P01	4320758	1982-03- 23		Eckenhoff et al.		
/		P02	4664651	1987-05- 12	1 1 1 1 1 1 1 1 1 1 1 1 1 1 1 1 1 1 1	Weinsbenker et al.		:
		P03	4671288	1987-06- 09	11,110 (100; 010) (101; 100) (101; 110) (101;	Gough		
		P04	4703761	1987-11- 03	TO TO STATE THAT THE COLD TO STATE	Rodion et al.		
١	1						)	

OIPE 49	
APR 1 6 2003	S S S S S S S S S S S S S S S S S S S
PROPERTY TRADERAN	



RECEIVED
APR 1 8 2003

TECHNOLOGY CENTER R3700

OIPE TO BE			
P24	5911223	1999-06- 15 Weaver et al.	
P25	5919159	1999-07- 06 Lilley et al.	

# Published Applications

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

	llinit	Citation No.	Patent Number	Date	Bar Code	Patentee	Class	Subclass
4)	5	UO1	1200100538911	2001- 12-20	1101601000 168 1101 1000 6100 6100 1000 1101 1100 1100 1100 1101	Ackley		

### Remarks

(Remarks are not for responding to an office action.)

This is Part One of a two-part Information Disclosure Statement. Part Two, citing non-U.S. Patent art, was filed this same day via First Class Mail. While the information and references disclosed in this Information Disclosure Statement may be "material" pursuant to 37 CFR 1.56, it is not intended to constitute an admission that any patent, publication or other information referred to therein is "prior art" for this invention unless specifically designated as such. In accordance with 37 CFR 1.97(g), the filing of this Information Disclosure Statement shall not be construed to mean that a search has been made or that no other material information as defined in 37 CFR 1.56(a) exists. Applicants further reserve the right to take appropriate action to establish the patentability of the disclosed invention over the listed documents should one or more of the documents be applied against the claims of the present application.

RECEIVED

APR 1 8 2003

Signature

TECHNOLOGY CENTER R3700

Examiner Name	Date
Alhand Storpso.	09/12/2ev4.

APP\_ID=10010723

page 3 of 3

PTO/SB/08A (10-01)
Approved for use through 10/31/2002.OMB 0651-0031
U. S. Patent and Trademark Office: U.S. DEPARTMENT OF COMMERCE and to a collection of information unless it contains a valid OMB control number.

Sub	stitute for form 1449A/F	то		Complete if Known		
				Application Number	10/010723	
11	VFORMATIO	ON DI	SCLOSURE	Filing Date	December 6, 2001	
S	STATEMEN <sup>T</sup>	ΓBY A	APPLICANT	First Named Inventor	Mark G. Allen	
				Art Unit	3763	
	(use as many sheets as necessary)			Examiner Name	Thompson, Kathryn L.	
Sheet	1	of	4	Attorney Docket Number	BVTP-P04-506	

			U.S. PAT	ENT DOCUMENTS	
Examiner Initials*	Cite No.1	Document Number  Number-Kind Code <sup>2</sup> (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
V X19	AA	2.893,392	07/07/1959	Wagner et al.	
- V-V	AB	3,034,507	05/15/1962	McConnell et al.	
	AC	3,086,530	04/23/1963	Groom	Dr.
	AD	3,123,212	03/03/1964	Taylor et al.	APR 1 8 200
-+-	AE	3,136,314	06/09/1964	Kravitz	10
	AF	RE 25,637	09/08/1964	Kravitz et al.	\ \ \ \ \ \ \ \ \ \ \ \ \ \ \ \ \ \ \
	AG	3,221,739	12/07/1965	Rosenthal	ECHA. 8 2
	AH	3,221,740	12/07/1965	Rosenthal	140000 <00
	AI	3,556,080	01/19/1971	Hein	OGY CO:
	ĀJ	3,596,660	08/03/1971	Melone	ENTED
-	AK	3,675,766	07/11/1972	Rosenthal	7773
<del></del>	AL	3,918,449	11/11/1975	Pistor	TECHNOLOGY CENTER AS
	AM	3,964,482	06/22/1976	Gerstel et al.	
<del></del>	AN	4,109,655	08/29/1978	Chacornac	
<del></del>	AO	4,159,659	07/03/1979	Nightingale	
	AP	4,222,392	09/16/1980	Brennan	
	AQ	4,771,660	09/20/1988	Yacowitz	<u> </u>
	AR	4,771,880	01/17/1989	Sarath et al.	
	AS	4,798,382	05/01/1990	Sibalis	
	AT		11/13/1990	Byers et al.	
		4,969,468	10/08/1991	Yacowitz	
	AU	5,054,339	08/11/1992	Kirkpatrick	
	AW	5,138,220 5,250,023	10/05/1993	Lee et al.	
			01/18/1994	Gross et al.	
	AX	5,279,544		Magnet	
	AY	5,279,552	01/18/1994	Fishman	
	AZ	5,335,670		Morrison et al.	
	BA	5,364,374	11/15/1994	Jarvis	
	BB	5,383,512	01/24/1995		
	BC	5,401,242	03/28/1995	Yacowitz Ginaven et al.	
-	BD	5,457,041	10/10/1995	Gross et al.	
-+	BE	5,527,288	06/18/1996	Erickson et al.	
	BF	5,582,184	12/10/1996	Lin et al.	
	BG	5,591,139	01/07/1997		
}	BH	5,611,806	03/18/1997	Jang Mamball et al	
	BI	5,611,809	03/18/1997	Marshall et al. Min	
	BJ	5,618,295	04/08/1997		
	BK	5,658,515	08/19/1997	Lee et al.	
	BL	5,697,901	12/16/1997	Eriksson	<del> </del>
	BM	5,801,057	09/01/1998	Smart et al.	<del></del>
	BN	5,843,114	12/01/1998	Jang	
1	BO	5,879,326	03/09/1999	Allen et al.	<del>-</del>
L	BP	6,050,988	04/18/2000	Zuck	

			•		
Examiner Signature	Kallad.	Monsto.	Date Considered	04/12	12004
		7° // ~		77	

PTO/SB/08A (10-01)

Approved for use through 10/31/2002.OMB 0651-0031
U. S. Patent and Trademark Office: U.S. DEPARTMENT OF COMMERCE

U. S. Patent and Trademark Office: U.S. DEPARTMENT OF COMMERCE Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it contains a valid OMB control number.

Substitute for form 1449A/PTO

Sheet

# INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

2 of 4

	Complete if Known	A A
Application Number	10/010723	
Filing Date	December 6, 2001	APP TY
First Named Inventor	Mark G. Allen	17016
Art Unit	3763	Par 200
Examiner Name	Thompson, Kathryn L.	CEN
Attomey Docket Number	BVTP-P04-506	

		FOREIG	GN PATENT I	DOCUMENTS	· · · · · · · · · · · · · · · · · · ·	$\neg$
Examiner	Cite	Foreign Patent Document	Publication Date	Name of Patentee or	Pages, Columns, Lines, Where Relevant	
Initials*	No.1	Country Code <sup>3</sup> -Number <sup>4</sup> -Kind Code <sup>3</sup> (if known)	MM-DD-YYYY	Applicant of Cited Document	Passages or Relevant Figures Appear	T⁵
111111	BQ	EP 0497620	05/08/1992	Carnegie-Mellon University		
	BR	EP 0 652 600	5/1995			
	BS	JP 7132119	05/23/1995	Nikon Corp.		
	BT	JP 7196314	08/01/1995	Maruo Calcium Co., Ltd.		
	ВŲ	WO 93/17754	09/16/1993	Elan Medical		
	BV	WO 96/37256	11/28/1996	Godshall		
	BW	WO 96/40365	12/1996			
	BX	WO 96/41236	12/19/1996	Regents of the University of CA		
	BY	WO 97/07734	03/06/1997	Spectrx, Inc.		
	BZ	WO 98/00193	01/08/1998	Altea Technologies		
	CA	WO 98/00194	01/08/1998	Sontra Medical		
	СВ	WO 98/28037	07/02/1998	Alza Corporation		
N /	*CC	WO 00/48669	08/24/2000	Biovalve Technologies		
	*CD	WO 00/74763	12/14/2000	Georgia Tech Research		

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant

<sup>1</sup> Applicant's unique citation designation number (optional). <sup>2</sup> See attached Kinds Codes of USPTO Patent Documents at <a href="https://www.uspto.gov">www.uspto.gov</a> or MPEP 901.04. <sup>3</sup>
Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). <sup>1</sup>For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the application number of the patent document. <sup>5</sup> Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. \*Applicant is to place a check mark here if English language Translation is attached.

	Cite	A CONTRACT OF THE CONTRACT OF	
	No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T²
WY	*CE	Abrams, S.B. Versatile biosensor is compact and cheap. Biophotonics International 32-34 (Jan/FEb 1998).	
700	CF	Amsden, B.G. and Goosen, M.F.A. Transdermal Delivery of Peptide and Protein Drugs: an Overview. AlChE J. 41, 1972-1977 (Aug. 1995).	
1	CG	Brumlik, C.J. and Martin, C.R. Template Synthesis of Metal Microtubules. J. Am. Chem. Soc. 113, 3174-3175 (1991).	
	*CH	Chun, K. et al. Fabrication of Array of Hollow Microcapillaries Used for Injection of Genetic Materials into Animal/Plant Cells. Jpn. J. Appl. Phys. 38, 279-281 (1999).	
	*CI	Clarke, M.S.F. and McNeil, P.L. Syringe loading introduces macromolecules into living mammalian cell cytosol. J. Cell. Sci. 102, 533-541 (1992).	
	CJ	Despont, M. et al. High-Aspect-Ratio, Ultrathick, Negative-Tone Near-UV Photoresist for Mems Applications. IEEE 0-7803-3744-1/97 (1997).	
CK Edell, D.J. et al. Factors Influencing the Biocompatibility of Insertable Silicon Microshafts in Cerebral Cortex. IEEE Transactions on Biomedical Engineering 39, 635-643 (1992).			

Examiner Signature MM S. Allamson. Date Considered Of Boury

PTO/SB/08A (10-01)

Approved for use through 10/31/2002.0MB 0651-0031

U. S. Patent and Trademark Office: U.S. DEPARTMENT OF COMMERCE Inder the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it contains a valid OMB control number.

Application Number

Substitute for form 1449A/PTO

### INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

for use through 10...

Office: U.S. DEPARTMEN.
In unless & contains a valid OMB ...

Implete if Known

10/010723

December 6, 2001

Mark G. Allen

Thryn L. Fliing Date First Named Inventor Art Unit Examiner Name

4 3 Sheet of Attorney Docket Number

	*CL	Eleventh Annual International Workshop on Micro Electro Mechanical Systems, Heidelberg, Germany (25-29 Jan. 1998). IEEE Catalog No. 98CH36176
	СМ	Frazier, A.B. and Allen, M.G. Metallic Microstructures Fabricated Using Photosensitive Polymide Electroplating Molds. J. Microelectromechanical Systems 2, 87-94 (June 1993).
	CN	Frazier, A.B. et al. Two Dimensional Metallic Microelectrode Arrays for Extracellular Stimulation and Recording of Neurons. IEEE 0-7803-0957 pp. 195-200 (Feb. 1993).
	CO	Haga et al. Transdermal lontophoretic delivery of insulin using a photoetched microdevice. J. Controlled Release 43, 139-149 (1997).
	СР	Hashmi, S. et al. Genetic Transformation of Nematodes Using Arrays of Micromechanical Piercing Structures. BioTechniques 19, 766-770 (Nov. 1995).
	CQ	Henry et al. Microfabricated Microneedles: A Novel Method to Increase Transdermal Drug Delivery. J. Pharm. Sci. 87, 922-925 (1998).
	CR	Henry, S. et al. Micromachined Needles: A Novel Approach to Transdermal Drug Delivery. J. Pharm. Sci. 87, 922-925 (Aug. 1998).
	CS	Hoffert, S.P. Transcutaneous Methods Get Under the Skin. The Scientist 12, no. 16 (17 Aug. 1998).
	*CT	Infiltrator Intramural Drug Delivery: A New Generation of Drug Delivery Catheters from InterVentional Technologies, Inc., San Diego, CA (1997).
	CU	Jaeger, R.C. Introduction to Microelectronic Fabrication in the Addison-Wesley Modular Series on Solid State Devices, G.W. Neudeck and R.F. Pierret, eds. Vol. 5, Addison-Wesley Publishing Co., Inc. (May 1993).
	CV	Jansen, H. et al. The Black Silicon Method IV: The Fabrication of Three-Dimensional Structures in Silicon with High Aspect Ratios for Scanning Probe Microscopy and Other Applications. MESA Res. Int, University of Twente, The Nethlerlands.
	CW	Laermer, F. et al. Bosch Deep Silicon Etching: Improving Uniformity and Etch Rate for Advanced MEMS Application. IEEE Catalog No. 99CH36291C, ISBN: 0-7803-5194-0 from the Twelfth IEEE International Conference on Micro Electro Mechanical Systems, Orlando FL, (17-21 Jan. 1999).
	СХ	Langer, R. Drug delivery and targeting. Nature 392 Supp, 5-10 (30 April 1998).
	CY	Lehmann, V. Porous Silicon – A New Material for MEMS. IEEE ISBN: 0-7803-2985-6/96 (1996).
	CZ	Lin, L. et al. Silicon Processed Microneedles. The 7 <sup>th</sup> International Conference on Solid-State Sensors and Actuators (1993).
V	DA	Martin, C.R. et al. Template Synthesis of Organic Microtubules. J. Am. Chem. Soc. 112, 8976-8977 (1990).

Date Considered Signature

PTO/SB/08A (10-01)
Approved for use through 10/31/2002.OMB 0651-0031
U. S. Patent and Trademark Office: U.S. DEPARTMENT OF COMMERCE

der the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it contains a valid OMB control number.

Substitute for form 1449A/PTO

### INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

4

Sheet of

	Complete if Known	
Application Number	10/010723	750
Filing Date	December 6, 2001	40.
First Named Inventor	Mark G. Allen ECK	77
Art Unit	3763	OLOGYO
Examiner Name	Thompson, Kathryn L.	CENT
Attorney Docket Number	BVTP-P04-506	10/2

DB Najafi, K. and Heltke, J.F. Strength Characterization of Silicon Microprobes in Neurophysiological Tissues. IEEE Transactions on Biomedical Engineering 37, 474-481 (May 1990).  DC 101 Uses for Tiny Tubules. Science 247 (23 March 1990).  DD Percutaneous Absorption, R.L. Bronaugh and H.I. Maibach, eds. Marcel Dekker, Inc., New York (1989).  DE Prausnitz, M.R. Reversible Skin Permeabilization for Transdermal Delivery of Macromolecules. Critical Reviews in Therapeutic Drug Carrier Systems 14, 455-483 (1997).  DF Proceedings of the IEEE Micro Electro Mechanical Systems Conference 1987-1998; Rai-Choudhury, ed., Handbook of Microlithography, Micromaching & Microfabrication (SPIE Optical Engineering Press, Bellingham, WA 1997.  DG Quan, M. Plasma etch yields microneedle arrays. Electronic Eng. Times, p.63 (13 July 1996).  1DH Reiss, S.M. Glucose- and Blood-Monitoring Systems Vie for Top Spot. Biophotonics International p. 43-46 (May/June 1997).  DI Runyan, W.R. and Bean, K.E. Semiconductor Integrated Circuit Processing Technology. Addison-Wesley Publishing Co. (1990).  DJ Schift, H. et al. Fabrication of replicated high precision insert elements for micro-optical bench arrangements. SPIE Vol. 3513, p. 122-134 from SPIE Conference on Microelectronic Structures and MEMS for Optical Processing IV, Santa Clara (Sept. 1998).  DK Single-crystal whiskers. Biophotonics Int'l, p. 64 (Nov/Dec. 1996).  DK Single-crystal whiskers. Biophotonics Int'l, p. 64 (Nov/Dec. 1996).  DK Transdermal Drug Delivery. J. Hadgraft and R.H. Guy, eds. Marcel Dekker, Inc., New York (1989).  DM Transdermal Drug Delivery. J. Hadgraft and R.H. Guy, eds. Marcel Dekker, Inc., New York (1989).  DN Trimmer, W. et al. Injection of DNA into Plant and Animal Tissues with Micromechanical Piercing Structures. IEEE Catalog No. 95cH35754, ISBN: 0-7803-2503-6 from Micro Electro Mechanical Systems, Amsterdam p. 111-115 (1995).  DO Weber, L. et al. Micro molding – a powerful tool for the large scale production of precise microstructures. SPIE No. 0-8194-2277-0/96	<del></del>		
DD Percutaneous Absorption, R.L. Bronaugh and H.I. Maibach, eds. Marcel Dekker, Inc., New York (1989).  DE Prausnitz, M.R. Reversible Skin Permeabilization for Transdermal Delivery of Macromolecules. Critical Reviews in Therapeutic Drug Carrier Systems 14, 455-483 (1997).  DF Proceedings of the IEEE Micro Electro Mechanical Systems Conference 1987-1998; Rai-Choudhury, ed., Handbook of Microlithography, Micromaching & Microfabrication (SPIE Optical Engineering Press, Bellingham, WA 1997.  DG Quan, M. Plasma etch yields microneedle arrays. Electronic Eng. Times, p.63 (13 July 1996).  DH Reiss, S.M. Glucose- and Blood-Monitoring Systems Vie for Top Spot. Biophotonics - International p. 43-46 (May/June 1997).  DI Runyan, W.R. and Bean, K.E. Semiconductor Integrated Circuit Processing Technology, Addison-Wesley Publishing Co. (1990).  DJ Schift, H. et al. Fabrication of replicated high precision insert elements for micro-optical bench arrangements. SPIE Vol. 3513, p.122-134 from SPIE Conference on Microelectronic Structures and MEMS for Optical Processing IV, Santa Clara (Sept. 1998).  DK Single-crystal whiskers. Biophotonics Int'l, p. 64 (Nov/Dec. 1996).  DL Talbot, N.H. and Pisano, A.P. Polymolding: Two Wafer Polysilicon Micromolding of Closed-Flow Passages for Microneedles and Microfluidic Devices. Solid-State Sensor and Actuator Workshop, Hilton Head Island, SC (8-11 June 1998).  DM Transdermal Drug Delivery. J. Hadgraft and R.H. Guy, eds. Marcel Dekker, Inc., New York (1989).  DN Trimmer, W. et al. Injection of DNA into Plant and Animal Tissues with Micromechanical Piercing Structures. IEEE Catalog No. 95CH35754, ISBN: 0-7803-2503-6 from Micro Electro Mechanical Systems, Amsterdam p. 111-115 (1995).	H.H.	, DR	Neurophysiological Tissues. IEEE Transactions on Biomedical Engineering 37, 474-481 (May
Prausnitz, M.R. Reversible Skin Permeabilization for Transdermal Delivery of Macromolecules. Critical Reviews in Therapeutic Drug Carrier Systems 14, 455-483 (1997).  DF Proceedings of the IEEE Micro Electro Mechanical Systems Conference 1987-1998; Rai-Choudhury, ed., Handbook of Microlithography, Micromaching & Microfabrication (SPIE Optical Engineering Press, Bellingham, WA 1997.  DG Quan, M. Plasma etch yields microneedle arrays. Electronic Eng. Times, p.63 (13 July 1996).  *DH Reiss, S.M. Glucose- and Blood-Monitoring Systems Vie for Top Spot. Biophotonics - International p. 43-46 (May/June 1997).  DI Runyan, W.R. and Bean, K.E. Semiconductor Integrated Circuit Processing Technology, Addison-Wesley Publishing Co. (1990).  DJ Schift, H. et al. Fabrication of replicated high precision insert elements for micro-optical bench arrangements. SPIE Vol. 3513, p.122-134 from SPIE Conference on Microelectronic Structures and MEMS for Optical Processing IV, Santa Clara (Sept. 1998).  DK Single-crystal whiskers. Biophotonics Int'l, p. 64 (Nov./Dec. 1996).  DL Talbot, N.H. and Pisano, A.P. Polymolding: Two Wafer Polysilicon Micromolding of Closed-Flow Passages for Microneedles and Microfluidic Devices. Solid-State Sensor and Actuator Workshop, Hilton Head Island, SC (8-11 June 1998).  DM Transdermal Drug Delivery, J. Hadgraft and R.H. Guy, eds. Marcel Dekker, Inc., New York (1989).  DN Trimmer, W. et al. Injection of DNA into Plant and Animal Tissues with Micromechanical Piercing Structures. IEEE Catalog No. 95CH35754, ISBN: 0-7803-2503-6 from Micro Electro Mechanical Systems, Amsterdam p. 111-115 (1995).  DO Weber, L. et al. Micro molding – a powerful tool for the large scale production of precise microstructures. SPIE No. 0-8194-2277-0/96, Vol. 2879, p.156-167 (1996).	1	DC	101 Uses for Tiny Tubules. Science 247 (23 March 1990).
Macromolecules. Critical Reviews in Therapeutic Drug Carrier Systems 14, 455-483 (1997).  DF Proceedings of the IEEE Micro Electro Mechanical Systems Conference 1987-1998; Rai-Choudhury, ed., Handbook of Microlithography, Micromaching & Microfabrication (SPIE Optical Engineering Press, Bellingham, WA 1997.  DG Quan, M. Plasma etch yields microneedle arrays. Electronic Eng. Times, p.63 (13 July 1996).  *DH Reiss, S.M. Glucose- and Blood-Monitoring Systems Vie for Top Spot. Biophotonics International p. 43-46 (May/June 1997).  DI Runyan, W.R. and Bean, K.E. Semiconductor Integrated Circuit Processing Technology, Addison-Wesley Publishing Co. (1990).  DJ Schift, H. et al. Fabrication of replicated high precision insert elements for micro-optical bench arrangements. SPIE Vol. 3513, p.122-134 from SPIE Conference on Microelectronic Structures and MEMS for Optical Processing IV, Santa Clara (Sept. 1998).  DK Single-crystal whiskers. Biophotonics Int'I, p. 64 (Nov./Dec. 1996).  DL Talbot, N.H. and Pisano, A.P. Polymolding: Two Wafer Polysilicon Micromolding of Closed-Flow Passages for Microneedles and Microfluidic Devices. Solid-State Sensor and Actuator Workshop, Hilton Head Island, SC (8-11 June 1998).  DM Transdermal Drug Delivery, J. Hadgraft and R.H. Guy, eds. Marcel Dekker, Inc., New York (1989).  DN Trimmer, W. et al. Injection of DNA into Plant and Animal Tissues with Micromechanical Piercing Structures. IEEE Catalog No. 95CH35754, ISBN: 0-7803-2503-6 from Micro Electro Mechanical Systems, Amsterdam p. 111-115 (1995).  DO Weber, L. et al. Micro molding — a powerful tool for the large scale production of precise microstructures. SPIE No. 0-8194-2277-0/96, Vol. 2879, p.156-167 (1996).		DD	
Choudhury, ed., Handbook of Microlithography, Micromaching & Microfabrication (SPIE Optical Engineering Press, Bellingham, WA 1997.  DG Quan, M. Plasma etch yields microneedle arrays. Electronic Eng. Times, p.63 (13 July 1996).  *DH Reiss, S.M. Glucose- and Blood-Monitoring Systems Vie for Top Spot. Biophotonics International p. 43-46 (May/June 1997).  DI Runyan, W.R. and Bean, K.E. Semiconductor Integrated Circuit Processing Technology. Addison-Wesley Publishing Co. (1990).  DJ Schift, H. et al. Fabrication of replicated high precision insert elements for micro-optical bench arrangements. SPIE Vol. 3513, p. 122-134 from SPIE Conference on Microelectronic Structures and MEMS for Optical Processing IV, Santa Clara (Sept. 1998).  DK Single-crystal whiskers. Biophotonics Int'l, p. 64 (Nov./Dec. 1996).  DL Talbot, N.H. and Pisano, A.P. Polymolding: Two Wafer Polysilicon Micromolding of Closed-Flow Passages for Microneedles and Microfluidic Devices. Solid-State Sensor and Actuator Workshop, Hilton Head Island, SC (8-11 June 1998).  DM Transdermal Drug Delivery, J. Hadgraft and R.H. Guy, eds. Marcel Dekker, Inc., New York (1989).  DN Trimmer, W. et al. Injection of DNA into Plant and Animal Tissues with Micromechanical Piercing Structures. IEEE Catalog No. 95CH35754, ISBN: 0-7803-2503-6 from Micro Electro Mechanical Systems, Amsterdam p. 111-115 (1995).  DO Weber, L. et al. Micro molding – a powerful tool for the large scale production of precise microstructures. SPIE No. 0-8194-2277-0/96, Vol. 2879, p.156-167 (1996).		DE	
*DH Reiss, S.M. Glucose- and Blood-Monitoring Systems Vie for Top Spot. Biophotonics International p. 43-46 (May/June 1997).  DI Runyan, W.R. and Bean, K.E. Semiconductor Integrated Circuit Processing Technology, Addison-Wesley Publishing Co. (1990).  DJ Schift, H. et al. Fabrication of replicated high precision insert elements for micro-optical bench arrangements. SPIE Vol. 3513, p. 122-134 from SPIE Conference on Microelectronic Structures and MEMS for Optical Processing IV, Santa Clara (Sept. 1998).  DK Single-crystal whiskers. Biophotonics Int'l, p. 64 (Nov./Dec. 1996).  DL Talbot, N.H. and Pisano, A.P. Polymolding: Two Wafer Polysilicon Micromolding of Closed-Flow Passages for Microneedles and Microfluidic Devices. Solid-State Sensor and Actuator Workshop, Hilton Head Island, SC (8-11 June 1998).  DM Transdermal Drug Delivery, J. Hadgraft and R.H. Guy, eds. Marcel Dekker, Inc., New York (1989).  DN Trimmer, W. et al. Injection of DNA into Plant and Animal Tissues with Micromechanical Piercing Structures. IEEE Catalog No. 95CH35754, ISBN: 0-7803-2503-6 from Micro Electro Mechanical Systems, Amsterdam p. 111-115 (1995).  DO Weber, L. et al. Micro molding – a powerful tool for the large scale production of precise microstructures. SPIE No. 0-8194-2277-0/96, Vol. 2879, p.156-167 (1996).		DF	Choudhury, ed., Handbook of Microlithography, Micromaching & Microfabrication (SPIE
International p. 43-46 (May/June 1997).  DI Runyan, W.R. and Bean, K.E. Semiconductor Integrated Circuit Processing Technology, Addison-Wesley Publishing Co. (1990).  DJ Schift, H. et al. Fabrication of replicated high precision insert elements for micro-optical bench arrangements. SPIE Vol. 3513, p.122-134 from SPIE Conference on Microelectronic Structures and MEMS for Optical Processing IV, Santa Clara (Sept. 1998).  DK Single-crystal whiskers. Biophotonics Int'l, p. 64 (Nov./Dec. 1996).  DL Talbot, N.H. and Pisano, A.P. Polymolding: Two Wafer Polysilicon Micromolding of Closed-Flow Passages for Microneedles and Microfluidic Devices. Solid-State Sensor and Actuator Workshop, Hilton Head Island, SC (8-11 June 1998).  DM Transdermal Drug Delivery, J. Hadgraft and R.H. Guy, eds. Marcel Dekker, Inc., New York (1989).  DN Trimmer, W. et al. Injection of DNA into Plant and Animal Tissues with Micromechanical Piercing Structures. IEEE Catalog No. 95CH35754, ISBN: 0-7803-2503-6 from Micro Electro Mechanical Systems, Amsterdam p. 111-115 (1995).  DO Weber, L. et al. Micro molding – a powerful tool for the large scale production of precise microstructures. SPIE No. 0-8194-2277-0/96, Vol. 2879, p.156-167 (1996).		DG	Quan, M. Plasma etch yields microneedle arrays. Electronic Eng. Times, p.63 (13 July 1996).
Addison-Wesley Publishing Co. (1990).  DJ Schift, H. et al. Fabrication of replicated high precision insert elements for micro-optical bench arrangements. SPIE Vol. 3513, p. 122-134 from SPIE Conference on Microelectronic Structures and MEMS for Optical Processing IV, Santa Clara (Sept. 1998).  DK Single-crystal whiskers. Biophotonics Int'l, p. 64 (Nov./Dec. 1996).  DL Talbot, N.H. and Pisano, A.P. Polymolding: Two Wafer Polysilicon Micromolding of Closed-Flow Passages for Microneedles and Microfluidic Devices. Solid-State Sensor and Actuator Workshop, Hilton Head Island, SC (8-11 June 1998).  DM Transdermal Drug Delivery. J. Hadgraft and R.H. Guy, eds. Marcel Dekker, Inc., New York (1989).  DN Trimmer, W. et al. Injection of DNA into Plant and Animal Tissues with Micromechanical Piercing Structures. IEEE Catalog No. 95CH35754, ISBN: 0-7803-2503-6 from Micro Electro Mechanical Systems, Amsterdam p. 111-115 (1995).  DO Weber, L. et al. Micro molding – a powerful tool for the large scale production of precise microstructures. SPIE No. 0-8194-2277-0/96, Vol. 2879, p. 156-167 (1996).		*DH	
arrangements. SPIE Vol. 3513, p.122-134 from SPIE Conference on Microelectronic Structures and MEMS for Optical Processing IV, Santa Clara (Sept. 1998).  DK Single-crystal whiskers. Biophotonics Int'I, p. 64 (Nov./Dec. 1996).  DL Talbot, N.H. and Pisano, A.P. Polymolding: Two Wafer Polysilicon Micromolding of Closed-Flow Passages for Microneedles and Microfluidic Devices. Solid-State Sensor and Actuator Workshop, Hilton Head Island, SC (8-11 June 1998).  DM Transdermal Drug Delivery, J. Hadgraft and R.H. Guy, eds. Marcel Dekker, Inc., New York (1989).  DN Trimmer, W. et al. Injection of DNA into Plant and Animal Tissues with Micromechanical Piercing Structures. IEEE Catalog No. 95CH35754, ISBN: 0-7803-2503-6 from Micro Electro Mechanical Systems, Amsterdam p. 111-115 (1995).  DO Weber, L. et al. Micro molding – a powerful tool for the large scale production of precise microstructures. SPIE No. 0-8194-2277-0/96, Vol. 2879, p.156-167 (1996).		DI	
DL Talbot, N.H. and Pisano, A.P. Polymolding: Two Wafer Polysilicon Micromolding of Closed-Flow Passages for Microneedles and Microfluidic Devices. Solid-State Sensor and Actuator Workshop, Hilton Head Island, SC (8-11 June 1998).  DM Transdermal Drug Delivery, J. Hadgraft and R.H. Guy, eds. Marcel Dekker, Inc., New York (1989).  DN Trimmer, W. et al. Injection of DNA into Plant and Animal Tissues with Micromechanical Piercing Structures. IEEE Catalog No. 95CH35754, ISBN: 0-7803-2503-6 from Micro Electro Mechanical Systems, Amsterdam p. 111-115 (1995).  DO Weber, L. et al. Micro molding – a powerful tool for the large scale production of precise microstructures. SPIE No. 0-8194-2277-0/96, Vol. 2879, p.156-167 (1996).		DJ	arrangements. SPIE Vol. 3513, p.122-134 from SPIE Conference on Microelectronic
Flow Passages for Microneedles and Microfluidic Devices. Solid-State Sensor and Actuator Workshop, Hilton Head Island, SC (8-11 June 1998).  DM Transdermal Drug Delivery, J. Hadgraft and R.H. Guy, eds. Marcel Dekker, Inc., New York (1989).  DN Trimmer, W. et al. Injection of DNA into Plant and Animal Tissues with Micromechanical Piercing Structures. IEEE Catalog No. 95CH35754, ISBN: 0-7803-2503-6 from Micro Electro Mechanical Systems, Amsterdam p. 111-115 (1995).  DO Weber, L. et al. Micro molding – a powerful tool for the large scale production of precise microstructures. SPIE No. 0-8194-2277-0/96, Vol. 2879, p.156-167 (1996).		DK	Single-crystal whiskers. Biophotonics Int'l, p. 64 (Nov./Dec. 1996).
(1989).  DN Trimmer, W. et al. Injection of DNA into Plant and Animal Tissues with Micromechanical Piercing Structures. IEEE Catalog No. 95CH35754, ISBN: 0-7803-2503-6 from Micro Electro Mechanical Systems, Amsterdam p. 111-115 (1995).  DO Weber, L. et al. Micro molding – a powerful tool for the large scale production of precise microstructures. SPIE No. 0-8194-2277-0/96, Vol. 2879, p.156-167 (1996).		DL	Flow Passages for Microneedles and Microfluidic Devices. Solid-State Sensor and Actuator
DN Trimmer, W. et al. Injection of DNA into Plant and Animal Tissues with Micromechanical Piercing Structures. IEEE Catalog No. 95CH35754, ISBN: 0-7803-2503-6 from Micro Electro Mechanical Systems, Amsterdam p. 111-115 (1995).  DO Weber, L. et al. Micro molding – a powerful tool for the large scale production of precise microstructures. SPIE No. 0-8194-2277-0/96, Vol. 2879, p.156-167 (1996).		DM	
microstructures. SPIE No. 0-8194-2277-0/96, Vol. 2879, p.156-167 (1996).		DN	Trimmer, W. et al. Injection of DNA into Plant and Animal Tissues with Micromechanical Piercing Structures. IEEE Catalog No. 95CH35754, ISBN: 0-7803-2503-6 from Micro Electro
DP Zuska, P. Microtechnology Opens Doors to the Universe of Small Space. MD&DI (1997).		DO	
		DP	Zuska, P. Microtechnology Opens Doors to the Universe of Small Space. MD&DI (1997).

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<sup>1</sup>Applicant's unique citation designation number (optional). <sup>2</sup>Applicant is to place a check mark here if English language Translation is attached.

·	 h_	/ ~ /	·	11	<i></i>		
Examiner Signature	7	alh	X	Al	logen -	Date Considered	09/10/2008/
		1	~	77			77.7